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Agenda

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- 3SPT within O-Net Group
- 3SP Technologies Overview
- 3SPT Product Portfolio

Nozay Wafer Fab Introduction

- Know-how
 - Process Flow: from Epitaxy to Chip-on-Submount
 - Core competencies: Mastering InP & GaAs Technologies

Organization and Facilities

- People / Facilities
- Equipment
- Capacities



Company Overview



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3SP Technologies: The Genesis

1994

Creation of Alcatel Optronics by the Alcatel Group

Investments and R&D => €480m // Alcatel Optronics owns 450 patents worldwide

2003

Acquisition of Alcatel Optronics by Avanex Corp. Company was renamed Avanex France

April 2007

Creation of 3S Photonics

Leading world supplier of laser chips, discrete modules and optical components, sole player for the 980nm submarine pump market

Management team raised €7.8m from Venture Capital, including the French's Strategic Investment Fund (FSI) in order to proceed with some acquisitions

February 2010

Acquisition of Avensys for €7.5m (incl. ITF Labs)

October 2011

Eurazeo acquires 83% of 3S Photonics Group for €37m

November 2011

3S Photonics acquires 100% of Manlight, company specialized in optical amplifiers, fiber lasers and LIDAR.

Manlight fully merged with 3S Photonics SA in March 2012

October 2014

O-Net Communications (Group) Ltd acquires assets of 3S Photonics and creates 3SP Technologies



3SPT Within O-Net Group

Global R&D, customer support and manufacturing footprint





3SPT Market Segment Within O-Net

	Undersea	Telecom/Datacom	Fiber Laser	Sensors
O-Net Communications 3SPTechnologies Source of Smart Solutions Her Brechnologies Monder of British Story				
Components	 980nm Pumps PIN Monitoring GFF, slope filters Undersea Gratings TAP Couplers WI & WDM Couplers 	 EA-laser modules DML & CW Lasers 980nm pumps DCF-based DCMs VOA, Interleaver GFF, Isolators, PD Mux/Demux, TF MPO/MTP AOC & Transceiver 	 1064nm Seed Lasers N:1,N+1:1 combiner/splitter, PM and kW class devices MFA, End cap, HR & Output Coupler Gratings 	 Unpackaged FBG Temperature sensors Strain sensors
Assemblies		"Build to print" Amplifier modules	AmplifiersCustomized Fiber lasers	Packaged fiber- based sensors
Engineering services	Custom GFF design	Line card (Blade) - assembly & testBack-end wafer processing	 Fiber laser and amplifier module design 	



3SP Technologies: Overview

- Founded in October 2014
 - Share capital: 1,800,000 Euros
 - Shareholder: Advance Photonics Investments Ltd (Hong Kong)
 - Under management contract with O-Net Communications
 - President: Mr Austin NA
 - General Manager: Mr Yannick BAILLY
- Location
 - Nozay (France): Approx. 8,250 sqm facilities
- Main activity
 - Design & manufacturing of laser chips & modules
- 2 subcontractors for back-end & packaging activities
 - Coset (Gwangju, Korea)
 - O-Net (Shenzhen, China)
- 95 employees
- Sales revenue: 13 M€ in 2015, 18 M€ in 2016
 - 95% of turnover from exports





Worldwide R&D and Production Organization

Multiple R&D sites

- Chip and CoS: 3SP Technologies (Nozay, France)
- Packaging:
 - ✓ O-Net (San Jose, USA; Shenzhen, China): design / process development
 - √ Coset (South Korea): design / process development
 - √ 3SP Technologies (Nozay, France): technical support

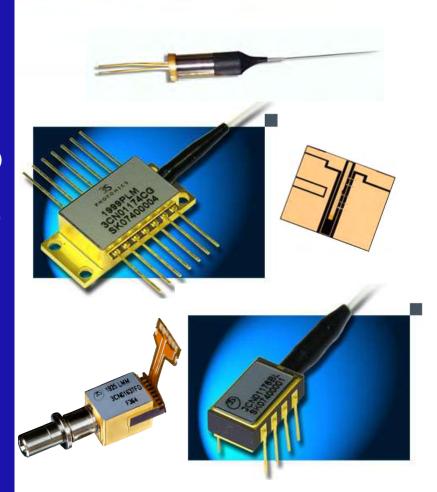
Three production sites

- One site for chips and chip on submount (CoS)
 - ✓ Since 1994, production site in 3SP Technologies (France)
- Two sites for Modules
 - ✓ Since 2007, production site in Coset (South Korea)
 - Mini-Dil, 14 pin Butterfly, 10 pin mini-Butterfly
 - ✓ Since 2016, production site in O-Net (Shenzhen, China)
 - TO can, 14 pin Butterfly

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Portfolio: Laser Chips and Modules

- 980nm uncooled 8-pin Mini-DIL up to 300mW
- 980nm cooled 14-pin BTF up to 950mW
- 14xxnm cooled 14-pin BTF up to 500mW
- 1064nm cooled 14-pin BTF up to 500mW
- 10-pin Mini-BTF 980nm cooled 450 to 680 mW (Q317)
- 10-pin Mini-BTF 980nm semi-cooled 440-540mW (Q317)
- 10-pin Mini-BTF 980nm cooled 700 to 950 mW (Q417)
- 10-pin Mini-BTF 980nm semi-cooled 600-750mW (Q118)
- 980nm cooled 14-pin BTF Gen2 450-680mW
- 980nm semi-cooled 14-pin BTF Gen2 440-540mW
- 980nm cooled 14-pin BTF Gen2 700-950mW (Q4 17)
- 980nm semi-cooled 14-pin BTF Gen2 600-750mW (Q1 18)
- 980nm uncooled TO can 50-200mW (Q1 18)
- C-Band Cooled 10G DWDM EML Laser
- C-Band Cooled CW & 2.5G DWDM DFB Laser
- Wide Band PIN Photodiode
- 25G 850nm VCSEL and PIN-PD



- Korea
- Shenzhen
- France



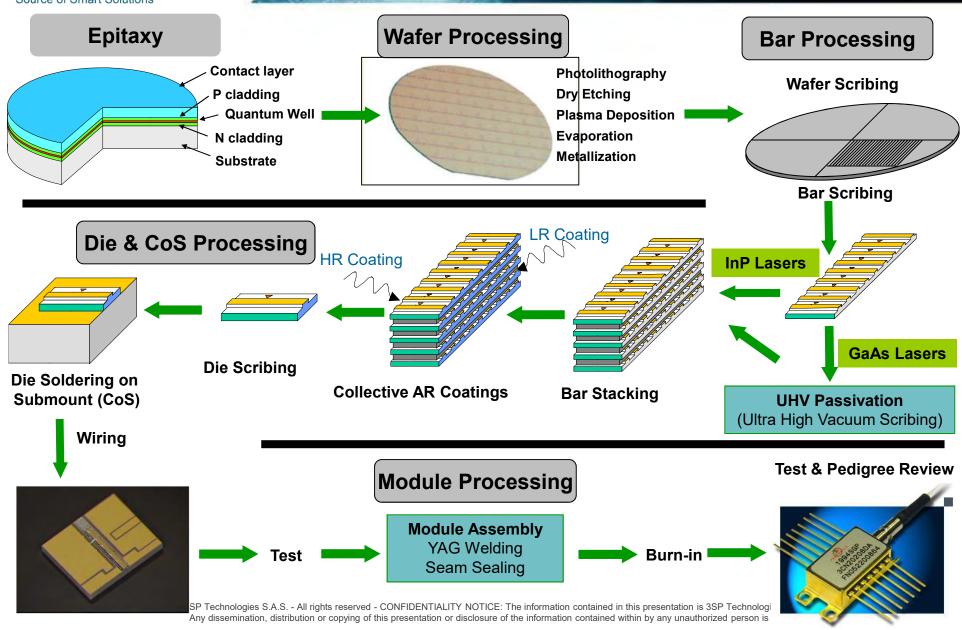
Wafer Fab Introduction



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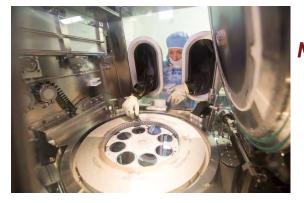
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Process Flow From Epitaxy to Chips on Submount





Core Competencies Mastering InP & GaAs Technologies

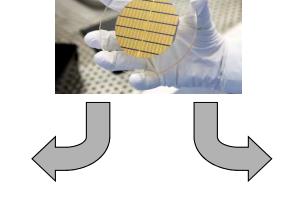












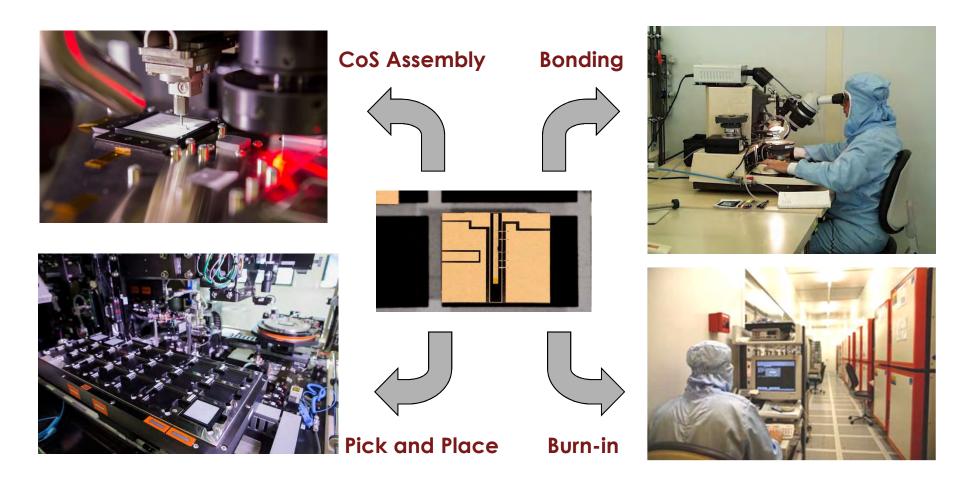




Strong Technical & Industrial Experience in Optoelectronic Wafer Processing
Unique « Building Block » Approach - Scalable Production Capacity



Core Competencies Mastering Die Technologies & Tests



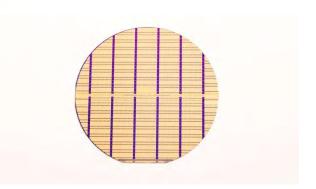
Strong Technical & Industrial Experience in Optoelectronic Die Assembly Scalable Production Capacity

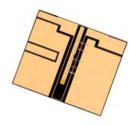


People / Facilities

PRODUCTION Nozay

- Manufacturing => 5 workshops
 - Epitaxy Wafer Processing Bar Die CoS
 - 3 engineers and 26 workers
- Process and Products Engineering
 - 6 engineers and 2 technicians
- Facilities and Maintenance
 - 2 engineers and 2 technicians





Nozay Factory => Total facilities = 8,250 m²

- Offices 900 m²

Workshops650 m²

Clean Rooms
 2,100 m² (ISO 6 and ISO 7)

Technical
 4,200 m² (Vacuum/Exhaust – Gas distribution – Air control)

- Others 400 m²



Nozay Wafer Fab Main Equipment

Epitaxy

1x MBE (InP), 2x MOVPE, X-Ray, PL map, C(V) Profiler

Wafer Processing

 1x DFB grating holographic bench, 2x Mask aligners, 2x PECVDs, 2x RIE, 1x RIE-ICP, 1x Evaporator, 2x Sputters, 2x IBE, 1x Lapping/polish, 2x Alloying Ovens, Profilers

Bars & Dies

 2x home-made UHV passivation (GaAs), bar stacking, IB coater, Evaporator, Ellipsometer, Reflectometer, 2x Probe-testers, 1x auto & 4x manual Die scribing (Loomis)

Chips on Submount

• 1x auto & 3x manual Die-bonders, 2x Wire-bonders, 6x CoS Testers, BI CoC-2A with approx. 4,000 slots











3SPT Wafer Fab Capacity

GaAs-based Technologies

980 Pump Dies
 500k dies

VCSEL Dies
 2 000k dies

InP-based Technologies

14XX Pump Dies
 250k dies

DFB LASER Dies
 2 000k dies

• 10G EML Dies 500k dies

Detectors
 2 000k dies



Thank You!



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